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OFFICIAL
PATENT
Docket No. 150.00560102IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	Lee et al.)	Group Art Unit:	1765
)		
Serial No.:	09/560,268)	Examiner:	Duy Deo
Confirmation No.:	2517)		
)		
Filed:	April 26, 2000)		
)		
For:	COMPOSITIONS FOR SELECTIVELY ETCHING AGAINST COBALT SILICIDE (As Amended)			

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The following is provided in response to the Office Action mailed October 22, 2003.

Remarks begin on the page entitled "Remarks."